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| APPLICATION NUMBER | FILING or 371(c)<br>DATE | GRP ART UNIT | FIL FEE REC'D | ATTY DOCKET NO | DRAWINGS | TOT CLAIMS | IND CLAIMS |
|--------------------|--------------------------|--------------|---------------|----------------|----------|------------|------------|
| 10/575,535         | 04/11/2006               | 2828         | 4600          | TCP-007        | 17       | 63         | 9          |

CONFIRMATION NO. 8918

## FILING RECEIPT

32628  
KANESAKA BERNER AND PARTNERS LLP  
1700 DIAGONAL RD  
SUITE 310  
ALEXANDRIA, VA22314-2848

Date Mailed: 03/02/2007

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## Applicant(s)

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## Assignment For Published Patent Application

National Institute for Materials Science, Tsukuba-shi, JAPAN

**Power of Attorney:** The patent practitioners associated with Customer Number 32628

## Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/17653 11/19/2004

## Foreign Applications

JAPAN 2003-391241 11/20/2003  
JAPAN 2003-391242 11/20/2003

**If Required, Foreign Filing License Granted:** 03/01/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/575,535**

**Projected Publication Date:** 06/07/2007

**Non-Publication Request:** No

## Early Publication Request: No

### Title

Wavelength conversion element having multi-gratings and light generating apparatus using said element, and wavelength conversion element having cylindrical ferroelectric single crystals and light generating apparatus using said element

### Preliminary Class

372

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